



## Room temperature CO gas sensing using Zn-doped In<sub>2</sub>O<sub>3</sub> single nanowire field effect transistors

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### ARTICLE INFO

#### Article history:

Received 26 April 2010

Received in revised form 26 July 2010

Accepted 28 July 2010

Available online 5 August 2010

#### Keywords:

Zn-doped In<sub>2</sub>O<sub>3</sub>

NW-FET

Doping

Sensing

Sensor response

### ABSTRACT

We demonstrate a room temperature sensing of CO gas (1–5 ppm) using high performance single Zn-doped In<sub>2</sub>O<sub>3</sub> nanowire field effect transistors (Zn-In<sub>2</sub>O<sub>3</sub> NW-FETs). Zn-In<sub>2</sub>O<sub>3</sub> nanowires were grown in a horizontal CVD furnace; single Zn-In<sub>2</sub>O<sub>3</sub> NW-FETs were fabricated using SiN<sub>x</sub> dielectric layer and bottom gate. Electrical measurements on the NW-FETs showed high performance devices, with a high “ON” current of  $8 \times 10^{-6}$  A at a 5V drain voltage, high on-off ratio of  $\sim 10^6$  and electron mobility of  $139 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$ . Sensing properties of CO gas were studied using these NW-FETs at room temperature. Doping of Zn<sup>2+</sup> into the In<sub>2</sub>O<sub>3</sub> NW enhances the sensor response compared to pure In<sub>2</sub>O<sub>3</sub> nanowire. A good selectivity of CO gas over NO and NO<sub>2</sub> can also be achieved. The improved sensor response at room temperature is attributed to the defects created and a change in conductivity of the nanowire upon Zn-doping. Significant negative threshold voltage shift of  $-3.5$  V was observed after exposure to a low concentration of CO gas at 5 ppm. This approach represents an important step towards the room temperature sensing of hazardous gas.

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### 1. Introduction

Among the sensing materials, oxides are widely used in the electrical detection of the pollutant gases due to their ability to change the conductivity when it comes in contact to the gas molecules. Semiconductor oxides such as In<sub>2</sub>O<sub>3</sub> [1–3], ZnO [4,5], SnO<sub>2</sub> [6], etc. are well explored for pollutant gases sensor. In order to increase the sensitivity, nanomaterials with higher surface area are advantageous [7]. There are various kind of nanostructures that have been used as sensors, including nanoparticles [8], nanowires [9–12], nanotubes [13], nanobelts [14], nanosheets [15], and nanocubes [16]. Single one-dimensional (1D) nanostructure based devices have attracted much attention due to their great miniaturization potential and large surface to volume ratio at nanoscale level which allows quick diffusion of gas molecules. As a result higher sensitivity and low detection limit with fast response and recovery time can be achieved even at lower working temperature range.

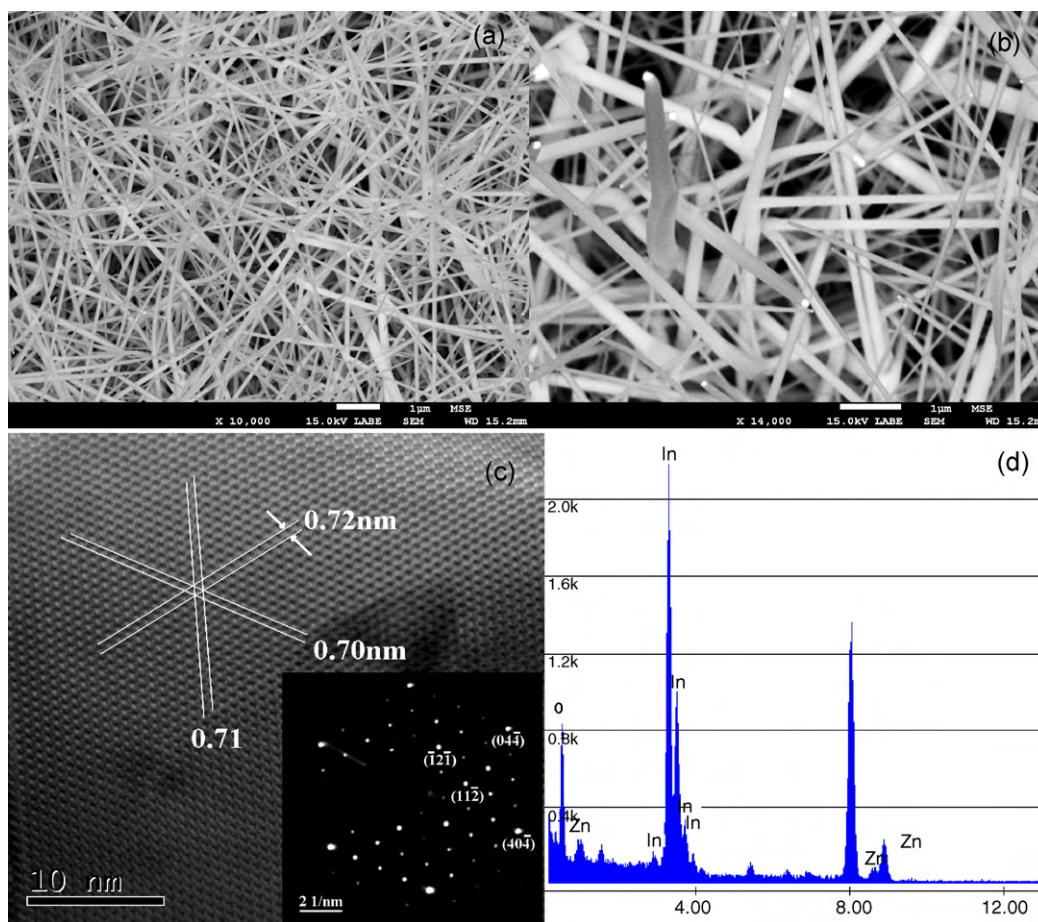
In room temperature operation, most of the gas sensors still face difficulties in getting a high response. Some reports have shown possible room temperature operation with higher sensitivity for NO<sub>2</sub> using In<sub>2</sub>O<sub>3</sub> nanowires [3]. In order to attain high response and selectivity, different approaches such as microstructure con-

trol, doping, raising operating temperature, etc. have been adopted to modify the sensing properties of semiconductor metal oxide gas sensors [17,18]. It is well known that the sensing mechanism is based on the surface reaction of the nanostructure with the exposed gas (adsorption and desorption of the test gas molecules). As adsorption is a surface effect, one can increase the adsorption of gas molecules by decorating with nanoparticles or doping with an element which has a stronger chemical affinity for that particular gas molecule. Doping in the nanowire can create defects and these defects play a role as preferential adsorption sites for gas molecule which can help to sense pollutant gases at lower temperature [19].

Carbon monoxide (CO) gas is one of the major pollutant gases in the environment and is mostly produced by the automobiles and industrial processes. It adversely affects human health at only a few parts per million. In most of the cases the CO gas detection sensitivity has been limited to 4–10 ppm with low response even at higher temperature [20,21]. Recently, Aruna et al. [22] have reported the ppb level detection of CO gas using SnO<sub>x</sub>-Pb nanoparticles at 350 °C and Joshi et al. [4] have reported a room temperature detection of 100 ppm CO gas using Au decorated ZnO NWs. There is no report on the detection of sub 10 ppm CO gas at room temperature in the best of our knowledge. The aim of this work is to overcome the requirement of high operation temperature for CO gas sensing of high sensitivity using nanowire field effect transistors. Here we report on the effect of Zn-doping on the sensing of CO gas at room temperature using high performance In<sub>2</sub>O<sub>3</sub> NW-FETs.

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**Fig. 1.** (a and b) FESEM images of the as-grown Zn-In<sub>2</sub>O<sub>3</sub> NW under low and high magnification, the images were captured in the low angle back scattered electron detection (LBE) mode, (c) HRTEM image of the Zn-In<sub>2</sub>O<sub>3</sub> NW, showing a family of {1 1 0} planes with inter planar distance 0.71 nm and in the inset SAD pattern is indexed and taken along [1 1 1] zone axis, (d) EDS pattern measured on a single Zn-In<sub>2</sub>O<sub>3</sub> NW, showing a series of In, O and weak Zn peaks.

## 2. Experimental work

Zn-In<sub>2</sub>O<sub>3</sub> NWs were grown in a horizontal CVD furnace at a source temperature of 900 °C [23]. The source for the growth was taken as a mixture of ZnO and In<sub>2</sub>O<sub>3</sub> with graphite powder. During the deposition, argon gas flow rate was fixed at 50 sccm and the pressure inside the quartz tube was maintained at 1 mbar. Si substrates with 9 nm gold layer were kept downstream and the substrate temperature ranges from 400 to 550 °C with deposition duration of 60 min. The as-grown Zn-In<sub>2</sub>O<sub>3</sub> samples were then annealed at 600 °C for 4 h in atmosphere.

The morphology of the as-grown samples was studied by field emission scanning electron microscopy (FESEM) on a JEOL 7600F scanning electron microscope operated at 5 kV. High resolution transmission electron micrographs (HRTEM) and selected-area diffraction (SAD) patterns were collected using a JEOL JEM 2010 microscope at an accelerating voltage of 200 kV. Energy-dispersive X-ray spectroscopy (EDS) analysis of a single nanowire was done on a JEOL JEM 2100F microscope. Photoluminescence studies were carried out at room temperature on a Cary Eclipse EL system at an excitation wavelength of 264 nm.

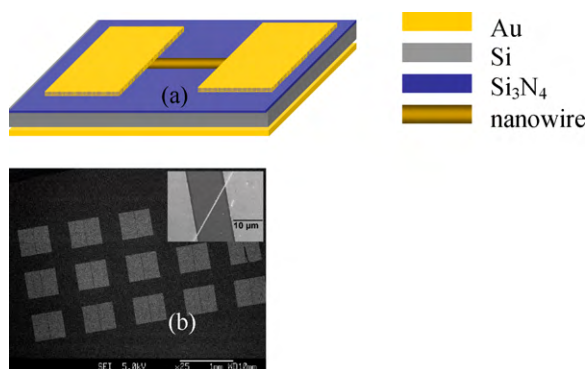
Zn-In<sub>2</sub>O<sub>3</sub> nanowire-based devices were fabricated on a highly doped n-type silicon wafer with a 60 nm SiN<sub>x</sub> high-*k* dielectric layer. Standard optical-lithography followed by Cr/Au (10/50 nm) deposition and liftoff was used to define the contact electrodes. The highly conductive Si substrate (resistivity 0.005 Ω cm) was used as a global back gate. Isopropyl alcohol (IPA) solution containing Zn-In<sub>2</sub>O<sub>3</sub> nanowires was prepared and drop-casted onto the Si sub-

strate. After drying, locations of nanowires on the pads (electrodes) were identified for fabricating nanowire-based field effect transistor (FET) structures. All the electrical and sensing measurements on the nanowire FET were done on a Keithley 4200-SCS semiconductor characterization system, attached with an optical microscope and sensing gases with gas controller under a humidity level of 50% at room temperature.

The sensor response (*S* %) is defined as,  $S\% = \frac{|\Delta R|}{R_0} \times 100$ , where  $\Delta R$  is the difference in resistances before and after gas exposure which is an absolute value, and  $R_0$  is the initial resistance of the nanowire sensor.

## 3. Result and discussion

The morphology of the as-grown Zn-In<sub>2</sub>O<sub>3</sub> NWs is shown in Fig. 1(a) and (b). The presence of the Au catalyst at the nanowire tip indicates the vapor-liquid-solid (VLS) nanowire growth mechanism. As shown in the FESEM images, the as-grown nanowires have a diameter of 50–300 nm and a length of 10–30 μm with circular cross-section. Fig. 1(c) shows a HRTEM image of the nanowire with an interplanar distance of 0.70 nm for {1 1 0} when viewing along ⟨1 1 1⟩. The SAD (in the inset of Fig. 1(c)) pattern was taken along [1 1 1] zone axis and indexed accordingly, which reveals that the nanowire has single crystalline cubic structure. In Fig. 1(d), the EDS pattern measured on a single Zn-In<sub>2</sub>O<sub>3</sub> NW showed a weak Zn peak with 1.6 at% Zn inclusion in the In<sub>2</sub>O<sub>3</sub> NW. It has been reported that the solubility of Zn in the In<sub>2</sub>O<sub>3</sub> lattice is low [22], which agrees well with our result. In addition, we have observed a



**Fig. 2.** (a) Schematic diagram of single nanowire FET, with Cr (10 nm)/Au (50 nm) serving as electrodes, SiN<sub>x</sub> serving as gate electrode and highly doped (resistivity 0.005 Ω cm) n-type Si as back gate, (b) FESEM image of a array of devices and in the inset a single NW-FET device touching the two electrodes with a channel length of 18 μm.

shift in the XRD peaks (supporting information S1) towards higher theta value, which confirms the presence of Zn in the In<sub>2</sub>O<sub>3</sub> lattice.

Fig. 2(a) shows a schematic illustration of a transistor based electrical sensor. Nanowires (with 1.6 at% Zn) were dispersed on a 60 nm SiN<sub>x</sub> high-*k* dielectric layer on Si substrate with patterned source and drain electrodes. The highly doped n-type Si substrate served as a back gate electrode and the chemical sensor was realized using this FET based sensor. Fig. 2(b) shows a representative FESEM image of the single Zn–In<sub>2</sub>O<sub>3</sub> NW bridging between two electrodes with a channel length of 18 μm. Similar nanowire transistors were fabricated using the undoped In<sub>2</sub>O<sub>3</sub> NWs.

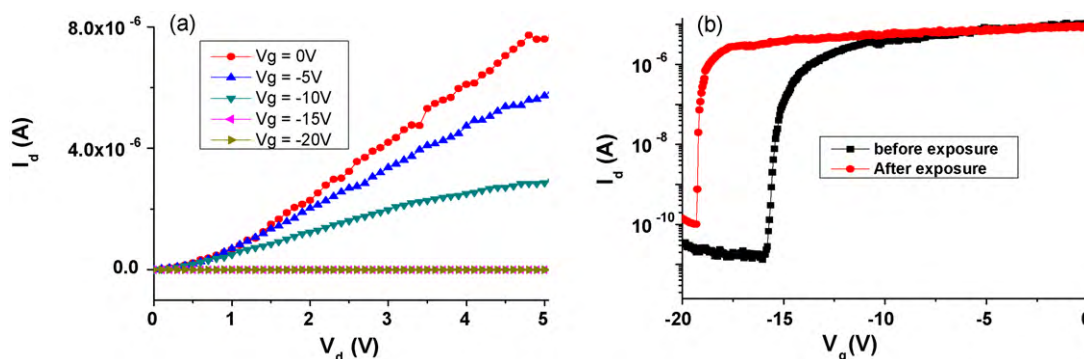
It is important and advantageous to realize highly functional NW-FET devices for the purpose of optimized sensing properties. It has been reported that Zn–In<sub>2</sub>O<sub>3</sub> NW-FET shows a remarkable n-type FET characteristics [22,24]. The transport properties of our single NW-FET device exhibited excellent n-type characteristics with strong gate control. The family curves for current–voltage ( $I_d$ – $V_d$ ) characteristics measured on a single nanowire as shown in Fig. 3(a), indicates a good conductivity of the nanowire with a high “ON” state current of  $8 \times 10^{-6}$  A at 5 V drain voltage ( $V_d$ ). Fig. 3(b) shows the  $I_d$ – $V_g$  curve recorded from the same device at  $V_d = 5$  V, with a linear behavior above a threshold voltage  $V_T$  of  $-15.65$  V. A sub-threshold swing value of  $\sim 140$  mV/decade and a drain–source current on/off ratio  $\sim 1 \times 10^6$  can be achieved, which are comparable to one of the best reported values [22]. The electron mobility ( $\mu_e$ ) was determined to be  $139 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$  in the linear operation region using the equation  $\mu = (1/C)[g_m](L^2/V_d)$  [21]; where,  $g_m$  is the transconductance ( $2.216 \mu\text{S}$ ),  $L$  is the nanowire channel length (18 μm) and  $C = 2\pi\epsilon\epsilon_0 L / \cosh^{-1}(1 + h/r)$  is the approximate

nanowire capacitance; where  $\epsilon$  is the dielectric constant of Si<sub>3</sub>N<sub>4</sub> ( $\sim 7$ ),  $h$  is the thickness of the Si<sub>3</sub>N<sub>4</sub> layer (60 nm), and  $r$  is the radius of the nanowire (125 nm). For the undoped single In<sub>2</sub>O<sub>3</sub> NW-FET a threshold voltage of  $-21.5$  V, an “ON” state current of  $8.5 \times 10^{-6}$  A with an on/off current ratio of  $5 \times 10^5$  was measured at 5 V drain voltage.

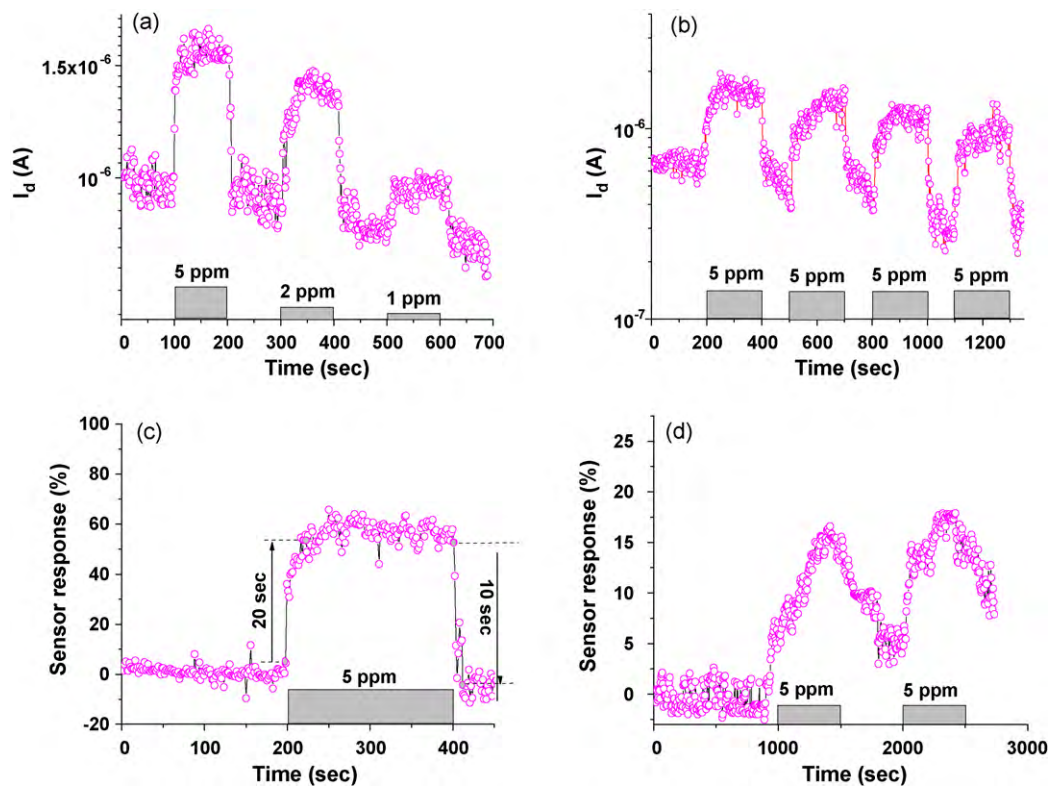
The Zn–In<sub>2</sub>O<sub>3</sub> NW-FET sensors were used for the detection of pollutant gas carbon monoxide (CO) at room temperature. The system was purged with N<sub>2</sub> gas to remove the excessive oxygen species from the surface of the nanowire and chamber. There was a slight current increment during the N<sub>2</sub> purge due to the partial desorption of the ionized oxygen species from the nanowire surface. Drain voltage ( $V_d$ ) was kept constant at 3 V and gate voltage ( $V_g$ ) was kept constant at  $-15$  V (which is in the threshold region of the NW-FET) during the measurements. The response of the Zn–In<sub>2</sub>O<sub>3</sub> NW sensor for 1–5 ppm CO gas is shown in Fig. 4(a). The change in the current for 1 ppm CO gas was not as significant as for 2 ppm and above (Fig. 4(a)). We can detect distinct electrical changes for the CO gas concentration down to 2 ppm using these Zn–In<sub>2</sub>O<sub>3</sub> NW sensors at room temperature. An increase in sensing current can be observed during CO gas exposure (Fig. 4(b)). As shown in Fig. 4(c), the sensor response plot of the Zn–In<sub>2</sub>O<sub>3</sub> NW sensor for 5 ppm CO gas shows a response time of 20 s and recovery time of 10 s, this is superior compared to the response time of the undoped In<sub>2</sub>O<sub>3</sub> NWs (Fig. 4(d)).

To further probe the selectivity of the Zn–In<sub>2</sub>O<sub>3</sub> NW sensor, we have measured the response of the same sensor to other pollutant gases including NO and NO<sub>2</sub> under the same conditions of drain bias voltage of 3 V and gate voltage  $V_g = -15$  V. The response of the Zn–In<sub>2</sub>O<sub>3</sub> NW sensor compared to different gases is shown in Fig. 5. It is evidently shown that the Zn-doped NW sensors attained a good selectivity of CO gas over NO and NO<sub>2</sub> at room temperature, despite a moderate response (30%) for 2 ppm NO<sub>2</sub> (which is considered as a highly oxidizing gas and has a threshold limit in sub ppb range). A negative threshold voltage ( $V_T$ ) shift of  $\sim 3.5$  V was measured after 5 ppm CO gas exposure at room temperature. This negative shift in threshold voltage can be explained in terms of the change in carrier concentration. After exposure to CO gas one can expect an increase in the electrons concentration in an n-type semiconductor. As CO gas molecules react with the ionized oxygen species and form CO<sub>2</sub>, electrons are released into the nanowire ( $\text{CO} + \text{O}^- \rightarrow \text{CO}_2 + \text{e}^-$ ). This can lead to a negative shift in the threshold voltage after exposure to CO gas due to the increased electrons concentration.

To understand the effect of Zn-doping in CO sensing, 5 ppm CO gas was tested at room temperature using both Zn-doped and undoped In<sub>2</sub>O<sub>3</sub> NWs. The response of the Zn–In<sub>2</sub>O<sub>3</sub> NW sensor was found to be almost 3 times higher than the undoped nanowire sensor with fast response and recovery time (Fig. 4(d)). The response and recovery time for the Zn–In<sub>2</sub>O<sub>3</sub> NWs sensor was found to be



**Fig. 3.** Electrical measurements done on the single NW-FET: (a) family of drain current–voltage ( $I_d$ – $V_d$ ) characteristics at different gate voltage ( $V_g$ ), (b)  $I_d$ – $V_g$  curve before and after 5 ppm CO gas exposure, showing a negative threshold voltage shift after exposure to CO gas for 1500 s.



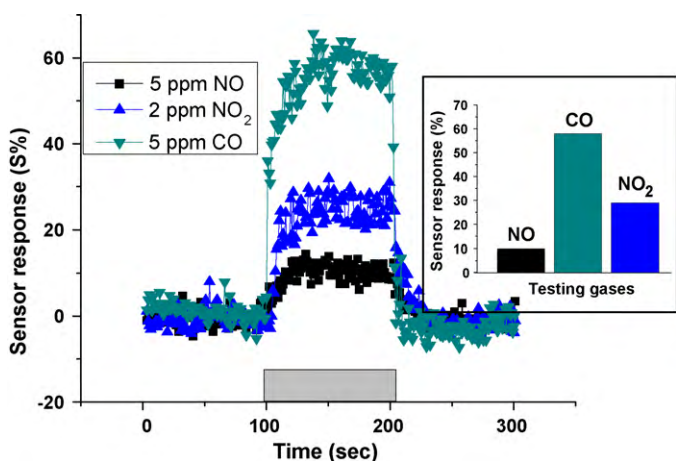
**Fig. 4.** Gas testing plots for sensor operated at room temperature: (a)  $I_d$ -time plot for the Zn- $\text{In}_2\text{O}_3$  NW sensor at different CO gas concentrations, (b)  $I_d$ -time plot measured on the Zn- $\text{In}_2\text{O}_3$  NW sensor when exposed to 5 ppm CO gas in different cycles, (c) sensor response plot of the Zn- $\text{In}_2\text{O}_3$  NW sensor for single cycle of 5 ppm CO gas, showing a response time of 20 s and recovery time of 10 s, (d) response plot for the undoped  $\text{In}_2\text{O}_3$  NW-FET, when exposed to 5 ppm CO gas in two cycles. The drain and gate voltages were kept constant at  $V_d = 3$  V and  $V_g = -15$  V, respectively, in all sensing experiments.

consistently improved, which shows that doping is playing a crucial role in enhancing the sensor response towards CO gas at room temperature. In addition to the nanowire properties, maintaining gate voltage ( $V_g$ ) near the threshold region while sensing is important as the devices are very sensitive to the change in carrier concentration at this voltage range and results in a quick response.

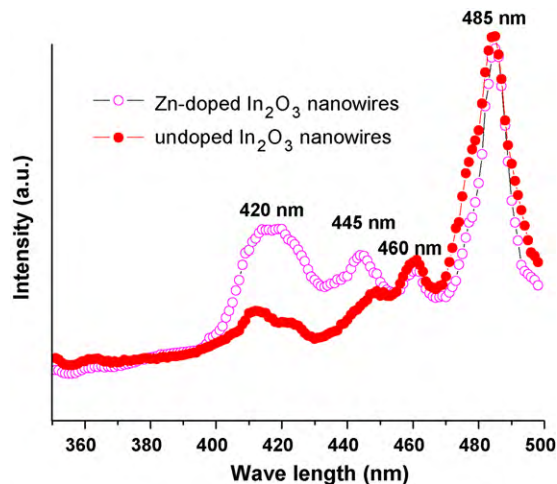
### 3.1. Sensing mechanism

The main effects of doping in oxide semiconducting nanowires are the change in electronic conductivity and the introduction of defects into the nanowires. These factors play an important role

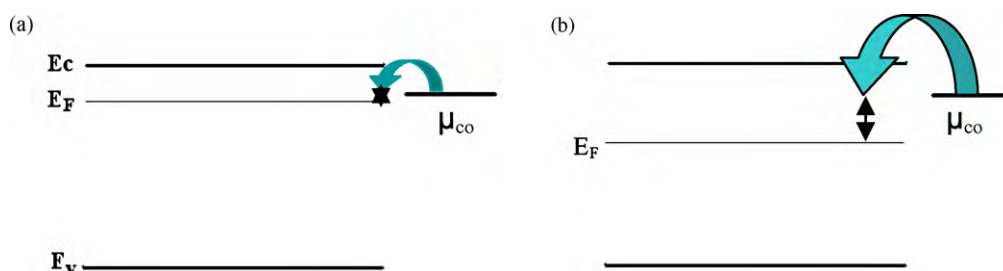
to enhance the sensitivity in nanowire sensors. Defects within the crystal structure can improve the adsorption of gas molecules on the nanowire surface [19] and the change in the conductivity will change the position of Fermi level in the energy band diagram which governs the electronic transportation between gas molecule and nanowire material. In addition, the electrical detection of any chemical species is dependent on the surface reactions between the nanowires and the chemical molecules. Since the amount of Zn insertion into the nanowires was found to be small ( $\sim 1.6\%$ ), it is unlikely that solely chemical affinity between Zn and CO can lead to the significant CO gas detection enhancement.



**Fig. 5.** Response of single Zn- $\text{In}_2\text{O}_3$  NW sensor to the different gases at a fixed  $V_d = 3$  V and  $V_g = -15$  V, sensor was operated at room temperature.



**Fig. 6.** Photoluminescence spectrum measured from the as deposited Zn-doped and -undoped  $\text{In}_2\text{O}_3$  NWs with an excitation wavelength of 264 nm at room temperature.



**Fig. 7.** Energy band diagram of (a) undoped  $\text{In}_2\text{O}_3$ , a n-type semiconductor, (b)  $\text{Zn-In}_2\text{O}_3$ , a less n-type semiconductor with  $E_F$  moved slightly towards  $E_v$  compared to undoped  $\text{In}_2\text{O}_3$ .  $\mu_{\text{co}}$  represents the chemical potentials of the CO molecule.

A plausible explanation on the improved sensing behavior in the doped semiconductor compared to undoped nanowires is related to the defects created by doping. Doping in nanowires can generate defects such as oxygen vacancies, metal interstitials, surface defects, etc. [25,26] and these defects play a vital role in the sensing of CO gas. The defects generated can be evaluated based on the PL spectrum (shown in Fig. 6) taken from the Zn-doped and undoped  $\text{In}_2\text{O}_3$  NWs under the excited wavelength of 264 nm of a Xe lamp. A series of PL peaks (420 nm, 445 nm, 460 nm and 485 nm) belonging to different types of defects [25,26] can be found. Additional PL peaks (420 nm and 445 nm) have been observed from the Zn-doped sample. These extra peaks can be attributed to the neutral and ionized oxygen vacancies ( $V_o$ ,  $V_o^-$  and  $V_o^{2-}$ ) and metal vacancies ( $V_{\text{In}}^{''}$ ) created by Zn-doping at high processing temperature [25]. At this stage we could not assign these PL peaks to the specific kind of defects, because a clear understanding on the photoluminescence behavior and its origin has not been achieved despite a huge number of reports. Most of the defects can play a role of as the preferential adsorption site for a gas molecule [19]. We suggest that this promotes the activation of doped nanowires even at room temperature when reacting with the testing gas.

Electronic transport between nanowire and CO gas molecule can be explained in terms of the transfer of electrons from CO gas molecule to the nanowire due to the chemical potential gradient between semiconducting  $\text{In}_2\text{O}_3$  nanowire and CO molecule [17]. It is well known that as-grown  $\text{In}_2\text{O}_3$  behaves as n-type semiconductor due to the existence of the native defects (metal interstitials, oxygen vacancies) in it. In the energy band diagram, the resultant position of  $E_F$  is nearer to  $E_C$  for undoped  $\text{In}_2\text{O}_3$  (shown in Fig. 7(a)) where  $E_C$ ,  $E_v$  and  $E_F$  correspond to the conduction band, the valence band and the Fermi level of the  $\text{In}_2\text{O}_3$  NWs. After Zn-doping, there is a slight increase (due to the low 1.6 at% Zn insertion) in the resistance (supporting information S2) but overall the nature of the  $\text{Zn-In}_2\text{O}_3$  NW still remains n-type. In the band diagram for  $\text{Zn-In}_2\text{O}_3$  NW,  $E_F$  can be slightly shifted towards  $E_v$  (Fig. 7(b)) compared to undoped  $\text{In}_2\text{O}_3$  band diagram (Fig. 7(a)). A chemical potential level  $\mu_{\text{co}}$ , is drawn for CO to represent the chemical potential of the electrons present in the gas molecule that can participate in the electron transfer process. An electron depletion region exists near the surface of the metal oxide nanowires because of the oxygen adsorption on the nanowire surface which extracts electrons from the nanowire, resulting in lower concentration of electrons near the nanowire surface. When CO molecules adsorb onto the  $\text{In}_2\text{O}_3$  NW surface, electrons transfer starts from a higher chemical potential to the material with a lower chemical potential until the system reaches equilibrium. For the undoped  $\text{In}_2\text{O}_3$  NW there is a smaller chemical potential gradient between the adsorbed CO molecule and the undoped  $\text{In}_2\text{O}_3$  compared to the  $\text{Zn-In}_2\text{O}_3$ . This results in the lesser electron transfer (to reach equilibrium) and therefore slower sensor response output with lower sensitivity for the undoped  $\text{In}_2\text{O}_3$  NWs. On the other hand, the larger difference in the chemical potential of the CO molecule and  $\text{Zn-In}_2\text{O}_3$  NW gives

us faster (response time 20 s and recovery time 10 s) and larger transfer of electrons, hence better sensor response can be achieved.

#### 4. Conclusions

We have developed a strategy to realize room temperature gas sensing using high quality  $\text{Zn-In}_2\text{O}_3$  NW channel in NW-FETs. The as fabricated device showed excellent operating characteristics with a high drain current on/off modulation ratio of  $10^6$ , a high on-state current of  $8 \times 10^{-6}$  A at  $V_d = 5$  V, a small sub-threshold gate voltage swing of 140 mV/decade and an electron mobility of  $139 \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$ . Gas sensing properties of such sensor has been studied for 1–5 ppm CO gas at room temperature. A negative threshold voltage shift of  $-3.5$  V was observed after exposure to 5 ppm CO gas. An enhanced sensor response and a good selectivity over NO and  $\text{NO}_2$  were achieved which have been correlated to the defects generated and the modification of the Fermi level in a  $\text{Zn-In}_2\text{O}_3$  NW due to the Zn-doping.

#### Acknowledgements

The authors gratefully acknowledge Prof. E. Comini and Dr. J. Yan for the insightful discussion and D. Fam, W. Ye for the technical support. N. Singh and C. Yan acknowledge the research scholarship provided by Nanyang Technological University, Singapore.

#### Appendix A. Supplementary data

Supplementary data associated with this article can be found, in the online version, at doi:10.1016/j.snb.2010.07.051.

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